

Electronic Patent Application Fee Transmittal

Application Number:	10533147			
Filing Date:	27-Apr-2005			
Title of Invention:	METHOD FOR PRODUCING SILICON WAFER			
First Named Inventor/Applicant Name:	Susumu Maeda			
Filer:	Gerald T. Shekleton/Mawish Elahi			
Attorney Docket Number:	94198			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appt Issue fee	1501	1	1440	1440
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Total in USD (\$)				1740